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648.41957CX1

UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: TAMURA et al

Serial No.: 10/658,291

Filed: September 10, 2003

For: Vacuum Processing Device And Vacuum  
Processing Method

Art Unit: 1763

Examiner: K. Moore

**AMENDMENT**

Mail Stop: Amendment (No Fee)  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

July 20, 2005.

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the Office Action dated April 20, 2005. The amendments are listed below and set forth on the following pages.

Amendments to the Specification;

Amendments to the Claims;

Amendments to the Abstract;

Remarks are included following the amendments.